Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination
10/632,082	LEE ET AL.
Examiner	Art Unit
Jason M. Han	2875

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SEARCHED					
Class	Subclass	Date	Examiner		
362	260	6/20/2005	JMH		
362	646	6/20/2005	ЈМН		
362	217-225	6/20/2005	ЈМН		
439	56	6/20/2005	ЈМН		
439	235	6/20/2005	ЈМН		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Search Update	6/20/2005	JMH		
P.E. Stephen Husar	6/20/2005	JMH		
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